PATENT APPLICATION

A. STEVENSON

Group Art Unit: 2812

Docket No.: 116565

Examiner:

INT AND TRADEMARK OFFICE IN THE UNITED STAT

In re the Application of

Tsuyoshi KANEKO et al.

Application No.: 10/649,891

Filed: August 28, 2003

OPTICAL COMPONENT AND MANUFACTURING METHOD THEREOF, For:

FEB 2 1 2006

MICROLENS SUBSTRATE AND MANUFACTURING METHOD THEREOF, DISPLAY

DEVICE, AND IMAGING DEVICE

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the reference(s) listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference(s) be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- \boxtimes This Information Disclosure Statement is being filed before the mailing date of a first Office Action on the merits after the filing of a Request for Continued Examination under 37 CFR §1.114. No certification or fee is required.
- \boxtimes In accordance with 37 CFR §1.98(a)(2)(ii), copies of any U.S. patents and patent application publications are not attached.

Respectfully submitted,

James A. Oliff

Registration No. 27,075

Gang Luo

Registration No. 50,559

JAO:GL/smo

Date: February 21, 2006

OLIFF & BERRIDGE, PLC P.O. Box 19928 Alexandria, Virginia 22320 Telephone: (703) 836-6400

DEPOSIT ACCOUNT USE **AUTHORIZATION** Please grant any extension necessary for entry; Charge any fee due to our Deposit Account No. 15-0461



Sheet <u>1</u> of <u>1</u>

Form PTO-1449 (REV. 1/06)		US Dept. of Commerce PATENT & TRADEMARK OFFICE		ATTY DOCKET NO. 116565		APPLICATION NO. 10/649,891			
INFORMATION DISCLOSURE STATEMENT									
(Use several sheets if necessary)			APPLICANT(S) Tsuyoshi KANEKO et al.						
			FILING		DATE GROUP 28, 2003 2812				
		U.	S. PATEN	L			l .		
Examiner Initials	Cite No.	Document Number	Da	ate Name		Name			
	1.	5,229,016	7/20/1993		Hayes et al.				
-	-								
			-						
	ii .								
FOREIGN PATENT DOCUMENTS									
Examiner Initials	Cite No.			ite	Country		With English Abstract	With English Translation	
								•	
OTHER DOCUMENTS									
Examiner Initials	Cite No.	(Including Author, Title, Date, Pertinent Pages, etc.)							
	•								
					,				
	·				-				
		12.00							
EXAMINER						DATE CONSIDERED			
Examiner:	Initial if	citation considered, whether or not citation	on is in co	nformanc	e with M.P.E.P. 609; draw line the	rough cita	tion if not in	conformance	

Date: February 21, 2006